L Number	Hits	Search Text	DB	Time stamp
2	175	(damascene) and (barrier with ("tungsten nitride" or "WN.sub.2")) and (barrier with cmp)	USPAT; US-PGPUB	2003/03/20 14:07
-	1818	(damascene) and ((barrier) same (CMP or polishing or polished))	USPAT; US-PGPUB	2003/03/19 19:27
-	42	((damascene) and ((barrier) same (CMP or polishing or polished))) and ald	USPAT; US-PGPUB	2003/03/19 12:16
-	419	((damascene) and ((barrier) same (CMP or polishing or polished))) and ("tungsten nitride" or "WN.sub.2")	USPAT; US-PGPUB	2003/03/19 14:44
-	398	(((damascene) and ((barrier) same (CMP or polishing or polished))) and ("tungsten nitride" or "WN.sub.2")) not (((damascene) and ((barrier) same (CMP or polishing or polished))) and ald)	USPAT; US-PGPUB	2003/03/19 12:17
-	7	("5091339" | "5262354" | "5451551" | "5863707" | "5935762" | "6004188" | "6017817").PN.	USPAT	2003/03/19 12:36
-	11	6110648.URPN.	USPAT	2003/03/19 12:38
-	6	("5702979" | "5785236" | "5923955" | "5985765" | "5989993" | "6090696").PN.	USPAT	2003/03/19 13:36
-	0	6440830.URPN.	USPAT	2003/03/19 14:16
-	4	("6015747" | "6074921" | "6140231" | "6271106").PN.	USPAT	2003/03/19 14:16
-	599	(damascene) and ((barrier) with (removing or removed or remove) with (top or surface or portion)) and ((remove or removing or removed) with (CMP or polishing or polished))	USPAT; US-PGPUB	2003/03/19 14:44
-	173	((damascene) and ((barrier) with (removing or removed or remove) with (top or surface or portion)) and ((remove or removing or removed) with (CMP or polishing or polished))) and ("tungsten nitride" or "WN.sub.2")	USPAT; US-PGPUB	2003/03/19 14:45
-	2	6313028.URPN.	USPAT	2003/03/19 14:51
-	15	("5674787" | "5897369" | "5969422" | "6008114" | "6025264" | "6027994" | "6037664" | "6130156" | "6150269" | "6156642" | "6184126" | "6187670" | "6197678" | "6204179" | "6211085").PN.	USPAT	2003/03/19 14:52
-	6	("5169680" | "5654245" | "5659201" | "5674787" | "5858877" | "5895261").PN.	USPAT	2003/03/19 14:57
-	28	6010962.URPN.	USPAT	2003/03/19 14:58
-	4	("6010962" | "6184138" | "6271136" | "6342447").PN.	USPAT	2003/03/19 15:00
-	15	(MOCVD or ("metal organic" adj1 (cvd or "chemical vapor"))) with "low temperature" with copper	USPAT; US-PGPUB	2003/03/20 11:39